

Form PTO 1449 (Modified)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY DOCKET NO. 200504US2		SERIAL NO. NEW APPLICATION	
LIST OF REFERENCES CITED BY APPLICANT				APPLICANT Takuji MATSUMOTO, et al.			
				FILING DATE HEREWITH		GROUP	
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						
	AM						
	AN						
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION YES NO		
	AO	58-124243	7/23/83	Japan (with English abstract)			X
	AP	11-87723	3/30/99	Japan (with English abstract0			X
	AQ	56-150853	11/21/81	Japan (with English abstract)			X
	AR	58-56450	4/4/83	Japan (with English abstract)			X
	AS	6-21373	1/28/94	Japan (with English abstract)			X
	AT	10-32266	2/3/98	Japan (with English abstract)			X
	AU	5-95116	4/16/93	Japan (with English abstract)			X
	AV	9-69610	3/11/97	Japan (with English abstract)			X
OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)							
	AW	Y. Hirano, et al., "Bulk-Layout-Compatible 0.18µm SOI-CMOS Technology Using Body-Fixed Partial Trench Isolation (PTI)" 1999 IEEE, International SOI Conference, October 1999., (Pgs.131-132, 19-25)					
	AX	T. Matsumoto, et al., "Clarification of Floating-Body Effects on Current Drivability in Deep Sub-Quarter Micron Partially-Depleted SOI MOSFET's" Extended Abstracts of the 1999 International Conference on Solid State Devices and Material, Tokyo, 1999., (Pgs. 340-341)					
	AY						
	AZ						
Examiner					Date Considered		

*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

09/29/16
 12/06/00
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SHEET 1 OF 1

Form PTO 1449 (Modified)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY DOCKET NO. 200504US2		SERIAL NO. 09/729,816	
LIST OF REFERENCES CITED BY APPLICANT				APPLICANT Takuji MATSUMOTO, et al.			
				FILING DATE December 6, 2000		GROUP	
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
210	AA	5,899,712	05/04/99	Ki Sik CHOI, et al.			
210	AB	5,767,549	06/16/98	Wei CHEN, et al.			
	AC						
	AD						
	AE						
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	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						
	AM						
	AN						
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION YES NO		
210	AO	WO 99/33115	07/01/99	WIPO			
210	AP	6-244180	09/02/94	JAPAN (with English Abstract)			X
210	AQ	WO 97/18585	05/22/97	WIPO			
	AR						
	AS						
	AT						
	AU						
	AV						
OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)							
	AW						
	AX						
	AY						
	AZ						
Examiner <i>Douglas L. Owens</i>					Date Considered <i>4/8/02</i>		

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